



App. No. 09/905,286

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,286  
Filing Date July 13, 2001  
Inventor Cem Basceri et al.  
Assignee Micron Technology, Inc.  
Group Art Unit 1762  
Examiner Fuller, Eric B.  
Attorney's Docket No. MI22-1724  
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate  
Comprising Dielectric Layers

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Cem Basceri et al.

Micron Technology, Inc.

1762

Fuller, Eric B.

MI22-1724

**RESPONSE TO JANUARY 29, 2003 FINAL OFFICE ACTION  
TO ACCOMPANY RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

**In the Claims**

Please replace the claims with the following clean version of the entire set of pending claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i).

A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.